



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akihisa HONGO et al.

Serial No. 09/762,582

Filed April 12, 2001

SUBSTRATE PLATING METHOD AND
APPARATUS

: **ATTN: BOX RCE**

: **Confirmation No. 5731**

: Docket No. 2001_0133A

: Group Art Unit 1753

: Examiner Brian Mutschler

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of

December 30, 2003.

The fee of \$110.00 is

submitted herewith.

to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

Small entity status of this application is established by a Small Entity Status Assertion which

is enclosed.

has been previously submitted.

Respectfully submitted,

04/20/2004 MAHMED1 00000008 09762582

02 FC:1251

110.00 0P

Akihisa HONGO et al.

By

David M. Ovedovitz

Registration No. 46,336

Attorney for Applicants

DMO/edg

Washington, D.C. 20006-1021

Telephone (202) 721-8200

Facsimile (202) 721-8250

April 16, 2004